

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1751**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2813

Application No.: 10/507,175

Examiner: C. RODGERS

Filed: September 10, 2004

Docket No.: 121026

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**AMENDMENT AFTER FINAL REJECTION
UNDER 37 CFR §1.116**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

*Do not enter
CR 15/06/07*

Sir:

In reply to the March 2, 2007 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.